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RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP ART UNIT 1765  
PATENT

Customer No. 22,852  
Attorney Docket No. 07553.0020-00000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Takeshi SAITO et al. ) Group Art Unit: 1765  
)  
Application No.: 09/807,896 ) Examiner: S. Ahmed  
)  
Filed: April 19, 2001 )  
) Mail Stop AF  
For: PLASMA ETCHING METHOD )  
)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**AMENDMENT AFTER FINAL**

In reply to the Final Office Action mailed September 24, 2003, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Please amend claims 1 and 12 as set forth in the Amendments to the Claims section of this Amendment After Final.

The **Amendments to the Claims** section begins on page 2 of this Amendment After Final.

**Remarks** begin on page 4 of this Amendment After Final.

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